## REMARKS

Attached is a marked-up version of the changes being made by the current amendment. Please apply any applicable charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: December 26, 2002

Scott (C. Harris

Reg. No. 32,030

KENYON S. JENCKES REG. NO 41,873

Fish & Richardson P.C.

PTO Customer No. 20985 \* \* \*

4350 La Jolla Village Drive, Suite 500

San Diego, California 92122 Telephone: (858) 678-5070 Facsimile: (858) 678-5099



## Version with markings to show changes made

## In the claims:

Claims 17-20 have been amended as follows:

- -- 17. (Amended) A method according to any one of claims 1, 2, 9 and 10, [to 16,] wherein said semiconductor layer comprises amorphous silicon.
- 18. (Amended) A method according to any one of claims 1, 2, 9 and 10, [to 16,] wherein said semiconductor layer comprises silicon and germanium.
- 19. (Amended) A method according to any one of claims 1, 2, 9 and 10, [to 16,] wherein the crystallized semiconductor layer contains carbon at a concentration not higher than  $5 \times 10^{18} \text{atoms/cm}^3$ .
- 20. (Amended) A method according to any one of claims 1, 2, 9 and 10, [to 16,] wherein the crystallized semiconductor layer contains oxygen at a concentration not higher than  $5 \times 10^{19} a toms/cm^3$ .